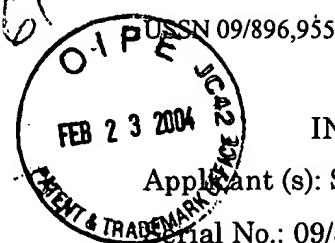


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1762



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED

Applicant(s): Steven M. George et al.

Serial No.: 09/896,955

Group Art Unit: 1762

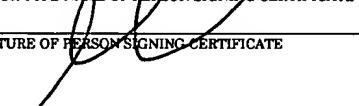
FEB 25 2004

Filed: June 29, 2001

Examiner: Meeks

For: METHOD FOR FORMING SiO₂ BY CHEMICAL VAPOR DEPOSITION AT ROOM TEMPERATURE

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING SENT BY FIRST CLASS MAIL ON February 18, 2004
DATE OF DEPOSIT
Gary C. Cohn
PRINT OR TYPE NAME OF PERSON SIGNING CERTIFICATE
SIGNATURE OF PERSON SIGNING CERTIFICATE



Hon. Commissioner of Patents & Trademarks
Washington, D.C. 20231

Sir:

RESUBMISSION OF RESPONSE

On January 6, 2004, the undersigned submitted a response, petition for extension of time, fee sheet and credit card authorization form to the USPTO by facsimile to telephone number 703-872-9306. Our facsimile machine printed a conformation report, indicating that the entire 9 pages of the facsimile were successfully sent to a fax machine that identified itself as "USPTO". However, no facsimile auto-transmission was received from the USPTO in response to the fax.

On February 17, Examiner Meeks of Art Unit 1762 called to inquire whether a response had been filed. Examiner Meeks informed us that the facsimile transmission had not been recorded by the USPTO.

Examiner Meeks suggested that we refile the response of January 6, 2004, without payment of additional fees.

Therefore, this paper is being filed to resubmit the papers that were filed on January 6.

Enclosed with this paper are:

- (1) Copy of the confirmation report generated by our fax machine, verifying that the January 6 fax was sent and received.

(2) Copy of the papers filed January 6, 2004. The copy of the credit card authorization form sent on January 6 has been marked "COPY".

Respectfully submitted,
GARY C. COHN PLLC

Gary C. Cohn
Registration No. 30,456
Phone: (425) 576-1656
4010 Lake Washington Blvd. NE
Suite 105
Kirkland, WA 98033

USSN 09/896,955



RECEIVED

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE FEB 25 2004

Applicant(s): Steven M. George et al.

Serial No.: 09/896,955

Group Art Unit: 1762

Filed: June 29, 2001

Examiner: Meeks

For: METHOD FOR FORMING SiO₂ BY CHEMICAL VAPOR DEPOSITION AT ROOM TEMPERATURE

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING SENT BY FACSIMILE ON January 6, 2004
DATE OF DEPOSIT
Gary Cohn
PRINT OR TYPE NAME OF PERSON SIGNING CERTIFICATE
SIGNATURE OF PERSON SIGNING CERTIFICATE

A handwritten signature "Gary Cohn" is written over the printed name and above the signature line.

Hon. Commissioner of Patents & Trademarks
Washington, D.C. 20231

Sir:

RESPONSE B

This paper is submitted in response to the office action in this case mailed August 6, 2003. A two-month extension of time is hereby requested. The required fee is being submitted with this paper.

The examiner is respectfully requested to enter the following amendments and to reconsider the application in view of the following remarks.

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